

<b>Notice of References Cited</b>	Application/Control No. 10/727,387		Applicant(s)/Patent Under Reexamination ROBINSON, KEVIN L.	
	Examiner Chuong A. Luu		Art Unit 2892	Page 1 of 1

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*	B	US-6,274,893	08-2001	Igarashi et al.	257/192
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	I	US-			
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	L	US-			
	M	US-			

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**NON-PATENT DOCUMENTS**

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